

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:	Yeo, <i>et al.</i>	Docket No.:	TSM03-0847
Serial No.:	10/826,602	Art Unit:	1795
Filed:	April 16, 2004	Examiner:	Raymond, Brittany L.
For:	Lithography Apparatus for Manufacture of Integrated Circuits		

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

Applicants respectfully submit the following amendments and remarks in response to Examiner's Office Action dated February 8, 2008. Applicants respectfully request that these amendments and remarks be entered, and respectfully request reconsideration of the claims.